

INTERNATIONAL SEARCH REPORT

International application No.
PCT/JP2005/003490

A. CLASSIFICATION OF SUBJECT MATTER
Int.Cl⁷ H05K3/42, 3/06

According to International Patent Classification (IPC) or to both national classification and IPC

B. FIELDS SEARCHED

Minimum documentation searched (classification system followed by classification symbols)
Int.Cl⁷ H05K3/42, 3/06

Documentation searched other than minimum documentation to the extent that such documents are included in the fields searched
Jitsuyo Shinan Koho / 1922-1996 Jitsuyo Shinan Toroku Koho 1996-2005
Kokai Jitsuyo Shinan Koho 1971-2005 Toroku Jitsuyo Shinan Koho 1994-2005

Electronic data base consulted during the international search (name of data base and, where practicable, search terms used)

C. DOCUMENTS CONSIDERED TO BE RELEVANT

Category*	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No.
X A	JP 7-142841 A (Nippon Abiotoronikusu Kabushiki Kaisha), 02 June, 1995 (02.06.95), Par. Nos. [0022] to [0033]; Figs. 1 to 2 (Family: none)	1 9
A	JP 2002-261424 A (Mitsubishi Paper Mills Ltd.), 13 September, 2002 (13.09.02), Full text (Family: none)	9
A	JP 2002-124765 A (NEC Toyama, Ltd.), 26 April, 2002 (26.04.02), Full text (Family: none)	9

Further documents are listed in the continuation of Box C.

See patent family annex.

* Special categories of cited documents:
"A" document defining the general state of the art which is not considered to be of particular relevance
"E" earlier application or patent but published on or after the international filing date
"L" document which may throw doubts on priority claim(s) or which is cited to establish the publication date of another citation or other special reason (as specified)
"O" document referring to an oral disclosure, use, exhibition or other means
"P" document published prior to the international filing date but later than the priority date claimed

"T" later document published after the international filing date or priority date and not in conflict with the application but cited to understand the principle or theory underlying the invention
"X" document of particular relevance; the claimed invention cannot be considered novel or cannot be considered to involve an inventive step when the document is taken alone
"Y" document of particular relevance; the claimed invention cannot be considered to involve an inventive step when the document is combined with one or more other such documents, such combination being obvious to a person skilled in the art
"&" document member of the same patent family

Date of the actual completion of the international search
26 May, 2005 (26.05.05)

Date of mailing of the international search report
14 June, 2005 (14.06.05)

Name and mailing address of the ISA/
Japanese Patent Office

Authorized officer

Faxsimile No.

Telephone No.

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Box No. II Observations where certain claims were found unsearchable (Continuation of item 2 of first sheet)

This international search report has not been established in respect of certain claims under Article 17(2)(a) for the following reasons:

1. Claims Nos.:
because they relate to subject matter not required to be searched by this Authority, namely:

2. Claims Nos.:
because they relate to parts of the international application that do not comply with the prescribed requirements to such an extent that no meaningful international search can be carried out, specifically:

3. Claims Nos.:
because they are dependent claims and are not drafted in accordance with the second and third sentences of Rule 6.4(a).

Box No. III Observations where unity of invention is lacking (Continuation of item 3 of first sheet)

This International Searching Authority found multiple inventions in this international application, as follows:

The inventions of claims 1-11 relate to a circuit board manufacturing method comprising the steps of forming a first resin layer on the surface of an insulating substrate having a conductive layer thereon, forming a second resin layer on the first resin layer on the surface conductive layer, and removing the first rising layer over a hole.

The inventions of claims 12-15 relate to a circuit board whether a land of a through hole and/or a blind hole is continuously formed concentrically with the hole, the maximum height of the conductive layer at a nonconnected portion of the land in relation to a reference point which is a corner part of the insulating substrate is (continued to extra sheet)

1. As all required additional search fees were timely paid by the applicant, this international search report covers all searchable claims.
2. As all searchable claims could be searched without effort justifying an additional fee, this Authority did not invite payment of any additional fee.
3. As only some of the required additional search fees were timely paid by the applicant, this international search report covers only those claims for which fees were paid, specifically claims Nos.:

4. No required additional search fees were timely paid by the applicant. Consequently, this international search report is restricted to the invention first mentioned in the claims; it is covered by claims Nos.: 1, 9

Remark on Protest

The additional search fees were accompanied by the applicant's protest.
 No protest accompanied the payment of additional search fees.

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Continuation of Box No.III of continuation of first sheet (2)

-5 μm or more and less than the thickness of the conductive layer of the circuit part, and the land width from the reference point is 0 to 40 μm . The two groups of inventions are not so linked to form a common single general inventive concept.

The technical feature common to claims 1-11 is a circuit board manufacturing method comprising the steps of forming a first resin layer on the surface of an insulating substrate having a conductive layer thereon, forming a second resin layer on the first resin layer on the surface conductive layer, and removing the first rising layer over a hole.

However, the international search has revealed that the circuit board manufacturing method comprising the steps of forming a first resin layer on the surface of an insulating substrate having a conductive layer thereon, forming a second resin layer on the first resin layer on the surface conductive layer, and removing the first rising layer over a hole is not novel since it is disclosed in document JP 7-142841 A (Nippon Avionics Co., Ltd.), 02 June, 1995 (02.06.95), Par. Nos. [0022] to [0032], Figs. 1, 2.

Consequently, since the a circuit board manufacturing method comprising the steps of forming a first resin layer on the surface of an insulating substrate having a conductive layer thereon, forming a second resin layer on the first resin layer on the surface conductive layer, and removing the first rising layer over a hole makes no contribution over the prior art, this common technical feature (a circuit board manufacturing method comprising the steps of forming a first resin layer on the surface of an insulating substrate having a conductive layer thereon, forming a second resin layer on the first resin layer on the surface conductive layer, and removing the first rising layer over a hole) cannot be considered as a special technical feature within the meaning of PCT Rule 13.2, second sentence.

The international search has reveled that the circuit board manufacturing method comprising the steps of forming a first resin layer on the surface of an insulating substrate having a conductive layer on the surface and on the inner wall of a through hole, forming a second resin layer insoluble or hardly soluble in a developer for the first resin layer on the first resin layer on the surface conductive layer, and removing the first resin layer over the hole by using the developer for the first resin layer is not novel since it is disclosed in document JP 7-142841 A (Nippon Avionics Co., Ltd.), 02 June, 95 (02.06.95), Par. Nos. [0022] to [0032], Figs. 1, 2.

Consequently, since the invention of claim 1 makes no contribution over the prior art and the other inventions depend on claim 1, the technical feature cannot be a special technical feature within the meaning of PCT Rule 13.2, second sentence.

Therefore, there is no "special technical feature" common to the inventions of claims 1-15 within the meaning of PCT Rule 13.2, second sentence, the inventions of claims 1-15 do not obviously satisfy the requirement of unity of invention.

A. 発明の属する分野の分類（国際特許分類（IPC））

Int.Cl.⁷ H05K3/42, 3/06

B. 調査を行った分野

調査を行った最小限資料（国際特許分類（IPC））

Int.Cl.⁷ H05K3/42, 3/06

最小限資料以外の資料で調査を行った分野に含まれるもの

日本国実用新案公報	1922-1996年
日本国公開実用新案公報	1971-2005年
日本国実用新案登録公報	1996-2005年
日本国登録実用新案公報	1994-2005年

国際調査で使用した電子データベース（データベースの名称、調査に使用した用語）

C. 関連すると認められる文献

引用文献の カテゴリー*	引用文献名 及び一部の箇所が関連するときは、その関連する箇所の表示	関連する 請求の範囲の番号
X	JP 7-142841 A (日本アビオニクス株式会社), 1995. 06. 02, 段落【0022】-【0033】、第1-2図 (ファミリーなし)	1
A	JP 2002-261424 A (三菱製紙株式会社), 2002. 09. 13, 全文 (ファミリーなし)	9
A	JP 2002-124765 A (富山日本電気株式会社), 2002. 04. 26, 全文 (ファミリーなし)	9

□ C欄の続きにも文献が列挙されている。

□ パテントファミリーに関する別紙を参照。

* 引用文献のカテゴリー

「A」特に関連のある文献ではなく、一般的技術水準を示すもの

「E」国際出願日前の出願または特許であるが、国際出願日以後に公表されたもの

「L」優先権主張に疑義を提起する文献又は他の文献の発行日若しくは他の特別な理由を確立するために引用する文献（理由を付す）

「O」口頭による開示、使用、展示等に言及する文献

「P」国際出願日前で、かつ優先権の主張の基礎となる出願

の日の後に公表された文献

「T」国際出願日又は優先日後に公表された文献であって出願と矛盾するものではなく、発明の原理又は理論の理解のために引用するもの

「X」特に関連のある文献であって、当該文献のみで発明の新規性又は進歩性がないと考えられるもの

「Y」特に関連のある文献であって、当該文献と他の1以上の文献との、当業者にとって自明である組合せによって進歩性がないと考えられるもの

「&」同一パテントファミリー文献

国際調査を完了した日

26. 05. 2005

国際調査報告の発送日

14. 6. 2005

国際調査機関の名称及びあて先

日本国特許庁 (ISA/JP)

郵便番号 100-8915

東京都千代田区霞が関三丁目4番3号

特許庁審査官（権限のある職員）

川内野 真介

3S 3324

電話番号 03-3581-1101 内線 3391

第II欄 請求の範囲の一部の調査ができないときの意見（第1ページの2の続き）

法第8条第3項（PCT17条(2)(a)）の規定により、この国際調査報告は次の理由により請求の範囲の一部について作成しなかった。

1. 請求の範囲_____は、この国際調査機関が調査をすることを要しない対象に係るものである。つまり、
2. 請求の範囲_____は、有意義な国際調査をすることができる程度まで所定の要件を満たしていない国際出願の部分に係るものである。つまり、
3. 請求の範囲_____は、従属請求の範囲であってPCT規則6.4(a)の第2文及び第3文の規定に従って記載されていない。

第III欄 発明の単一性が欠如しているときの意見（第1ページの3の続き）

次に述べるようにこの国際出願に二以上の発明があるとこの国際調査機関は認めた。

請求の範囲1-11は、表面に導電層を有する絶縁性基板の表面に第一樹脂層を形成する工程、表面導電層上の第一樹脂層上に、第二樹脂層を形成する工程、孔上の第一樹脂層を除去する工程を含む回路基板の製造方法の発明であり、

請求の範囲12-15は、貫通孔および／または非貫通孔のランドが該孔に対して同心円状に連続して形成されており、絶縁性基板の角部を基準点として、ランドの非連結部における導電層の最大高さが $-5 \mu m$ 以上、回路部の導電層の厚み以下であり、また該基準点からのランド幅が $0 \sim 40 \mu m$ である回路基板の発明であり、共通する単一の一般的発明概念を形成するように連関してはいない。

1. 出願人が必要な追加調査手数料をすべて期間内に納付したので、この国際調査報告は、すべての調査可能な請求の範囲について作成した。
2. 追加調査手数料を要求するまでもなく、すべての調査可能な請求の範囲について調査することができたので、追加調査手数料の納付を求めなかった。
3. 出願人が必要な追加調査手数料を一部のみしか期間内に納付しなかったので、この国際調査報告は、手数料の納付のあった次の請求の範囲のみについて作成した。
4. 出願人が必要な追加調査手数料を期間内に納付しなかったので、この国際調査報告は、請求の範囲の最初に記載されている発明に係る次の請求の範囲について作成した。

請求の範囲1, 9

追加調査手数料の異議の申立てに関する注意

追加調査手数料の納付と共に出願人から異議申立てがあつた。
 追加調査手数料の納付と共に出願人から異議申立てがなかつた。